Research Article

Modal Analysis of a Single-Structure Multiaxis MEMS Gyroscope

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This paper reports on designing a single-structure triaxes MEMS capacitive gyroscope which is capable of measuring the three angular velocities on a single drive. A Z-shaped beam for the support of folded coupling spring has been applied to suppress the unwanted mode and decrease the stress effect at the spring ends. The unique coupling spring has changed the driving motion, due to which slide film damping in the driving mode has been reduced. This reduction can lead to higher performance of the sensor with less requirements on vacuum level which decreases the cost of fabrication. Simulation analysis has been performed in COMSOL Multiphysics and Matlab Simulink to finalize the design for fabrication. After finite element analysis, the driving, $x$-sensing, $z$-sensing, and $y$-sensing are, respectively, found to be 13.30 KHz, 13.40 KHz, 13.47 KHz, and 13.51 KHz.

1. Introduction

Most of today’s inertial sensors are based on microelectromechanical systems (MEMS). Due to the use of MEMS technology, the contemporary sensors are of light weight in design, low cost, and compact size. With MEMS, sensors have the added advantage of achieving high performance with low power consumption [1]. MEMS inertial sensors comprise gyroscopes and accelerometers. Accelerometers and gyroscopes play an important role in the MEMS industry among sensors. Gyroscope is used to measure the angular rotations about the three perpendicular axes, that is, $x$-, $y$-, or $z$-axis, while accelerometer is used to sense the linear acceleration. Gyroscope which is used to measure a single axis rotation is called a single-axis gyroscope while the gyros that are used to sense more than one axis are called multiaxis gyroscopes. Mostly, single-axis gyroscopes are $z$-axis designed with different approaches as identified in the research studies [2–5]. Also, many multiaxis gyroscope designs have been published for sensing two or three axis angular velocities [5–8]. In [7, 8], the presented designs need three separate drive voltages as they are based on three drive structures. These designs, however, result in complex circuitry and more power consumption.

Due to small size and high performance, single-structure triaxes gyroscopes are aimed for MEMS sensor industries nowadays. The use of single structure in gyroscopes not only simplifies electronics design but also leads to low power, low cost, and reduced noise in the overall system. These advantages pave ways for wide applications of inertial measurement units (IMUs) in industries, for example, electronic stability control, body motion dynamics, mobile gaming, and image stabilization to name a few.

To win space, most MEMS IMUs designs combine two in-plane accelerometers and gyroscopes ($x$- and $y$-axes) with an out-of-plane accelerometer and gyroscope ($z$-axis), which permits placing all sensors on a single chip [9]. Single drive mass has an advantage to adjust all the gyroscopes ($x$-, $y$-, and $z$-gyros) inside a single structure which has reduced 6-degree-of-freedom (6-DOF) IMU die size and the cost of the MEMS sensing element [10, 11].

Motion sensing combo sensors are a hot topic owing to the wide applications of IMUs as well as in terms of market
potential and competition among the players. Recently, due to the growing trend of 6- and 9-DOF devices applications, the field leaders (e.g., STMicroelectronics, Bosch, Invensense, AKM, and mCube to name a few) have devised innovative technical solutions, to have the right patents [12, 13] to protect their inventions.

For improving the IMUs performance and size reduction, a number of different designs have been published targeting single-structure triaxes MEMS gyroscopes [13–16]. The study of [13] suggests an integrated single drive three-axis MEMS gyroscope with improved driving structure where the improved driving movements have been achieved by using folded coupling springs. Coupling drive masses ensure their synchronous movement with a given phase due to elastic coupling elements. For coupling of drive masses and enabling their synchronous movement with each other, the authors in [15] suggested U-shaped synchronizing springs near the center of the device. The study of [16] has proposed a vibratory ring spring in their presented design which makes all sensing schemes necessary for 3-axis angular rate. Another single-structure triaxis gyro design has been patented in [17]; however, the proposed gyro design has used the anchor in the coupling spring system which can have anchor losses during the drive-mode operation. Furthermore, the use of these anchors also increases the complexity and fabrication steps.

The conflict between STMicroelectronics and Invensense has also opened new ways for the researchers in terms of single-structure triaxes gyroscopes. For example, a single-structure 3-axis gyro has been analyzed to reduce the drive-force coupling by using secondary auxiliary mass [18]. In [19], authors have proposed a single-drive mass gyroscope with a high resonant frequency.

In MEMS motion sensors design, elastic elements play very significant role. This is due to the fact that the designed spring beams, being able to deliver the desired transduction, can transfer vibration and bring improvement in the impact to the system. Since, the gyroscope is affected by the external forces and acceleration, therefore, it becomes pivotal to provide the elastic coefficient of the vibration system along with alleviation of the external impact by the spring beams. For this purpose, a number of studies have been done on the elastic elements [20, 21]. In [21], the authors have analyzed the performance of commonly used springs in MEMS sensor technology.

Folded springs have been used in many published MEMS inertial sensors designs due to the low cross-axis errors [22] and perfect motions of the moving parts of those sensors. Also, in single-structure MEMS gyroscopes designs, the folded or U-shaped spring is used mostly for the coupling of the drive masses. Joining the individual drive masses into single one requires coupling spring. Almost, all the previous suggested designs propose the usage of same typical coupling spring. For example, the designs proposed in [15, 16] suggest the use of U-shaped coupling springs. However, U-shaped and folded coupling springs result in higher stress fracture as compared to the new unique coupling spring suggested in this paper, which is attached at two points with the driving mass. Due to single point of attachment of U-shaped and folded coupling springs to the driving mass, they receive large stress effect at the end points (Figure 3(b)) which can lead to the spring breakage during the operation.

In this paper, a single-structure triaxial MEMS gyroscope has been proposed with a unique coupling spring. The Z-shaped beam has been introduced for the support of the folded spring and to suppress the unwanted mode. The coupling spring is composed of folded spring supported by a Z-shaped beam. The work presented in this letter is an extension of our previous study [23] in which the design has been thoroughly analyzed and results have been presented after extensive simulation of the design in COMSOL Multiphysics and Matlab Simulink.

2. Structural Analysis of the Proposed Design

The proposed design is a single-structure triaxis MEMS capacitive gyroscope with the dimension of 1428 μm × 1428 μm. The device is anchored at five positions. The gyroscope comprises four driving masses coupled by the four coupling spring as shown in Figure 1. The proposed design is capable of measuring pitch, roll, and yaw angular velocities where electrode plates can be placed on the substrate beneath the x- and y-sensing proof masses. With the applied roll angular velocity, Ωz, to the MEMS gyroscope, electrodes beneath the y-sensing proof masses are used to sense the applied roll angular velocity, Ωx. Similarly, the pitch angular velocity, Ωy, is sensed by utilizing the electrodes beneath the x-sensing proof masses. Moreover, for sensing yaw angular velocity, each of the Z-sense masses includes Z-sense movable and fixed electrodes. To find the yaw angular velocity, Ωz, the changes in capacitance between fixed and movable electrodes are measured. When a yaw angular velocity, Ωz, is applied to the MEMS gyroscope, the two Z-sensing masses move in y-direction opposite to each other. In this way, a change in capacitance occurs between fixed and movable electrodes. Figure 1 shows the proposed gyroscope, containing the fixed parts and moving mass. A further simplified model of the proposed gyroscope is represented in Figure 2. In Figure 2, Ks represents the coupling spring, which is used to couple the driving masses. The simulation results of the resonant frequencies from COMSOL are shown in Figure 3.

2.1. Coupling Spring. The spring beams, which deliver the desired transduction, play an important role in MEMS gyroscope design. The presented gyroscope has more elastic elements which have been properly distributed in the design to make all the motions useful. Almost the same folded coupling spring has been used in the prior published gyroscope designs. The proposed design contains a unique coupling spring which comprises a Z-shaped beam and folded spring.

A Z-shaped beam is introduced for the support of the folded spring. The coupling spring has the following effects:

(i) It reduces stress on the spring ends as the spring is attached at two points with the driving mass.
(ii) It has changed the driving mass motion which has a reduced slide film damping effect in the outside static and moving driving electrodes.
Due to the use of the Z-shaped beam with the folded spring, the unwanted mode has been suppressed.

2.2. Effect of Z-Shaped Beam. The effect of coupling spring in the design has been analyzed. The design is simulated with and without Z-shaped beam. The differences between the final required mode and the unwanted mode (next to the final required mode) were compared in both spring cases. The design with Z-shaped beam in the coupling spring (S1) was found to have large frequency difference ($\Delta f$) between the final required and unwanted frequency modes as compared to the design without the Z-shaped beam in the coupling spring (S2). The frequency difference between the required and unwanted modes is, respectively, 2072 Hz and 825 Hz of the designs with and without Z-shaped beams. On the basis of this analysis, the design with the Z-shaped beam for the support of the folded spring is better as compared to the design without the Z-shaped beam, as it suppressed the unwanted mode shown in the design without the Z-shaped beam. Moreover, the coupling spring with Z-shaped beam has a less stress effect at the spring ends attached to the drive mass as compared to the design without the Z-shaped beam in the coupling spring as shown in Figure 4. The reason behind the less stress effect is that the Z-shaped beam coupling spring is attached at a two points to the drive mass. The two designs with different coupling springs and the resonant frequencies are shown in Figure 5 (design with Z-shaped beam in coupling spring) and Figure 6 (design without Z-shaped beam in coupling spring). Figure 7 shows the graph of frequency difference between two modes of the design with two different coupling springs S1 and S2.

3. Slide Film Damping Estimation in Driving Mode

Generally, damping due to the surrounding air can be ignored for a conventional mechanical machine because the energy dissipated by air damping is much smaller than the energy dissipated by other mechanisms. However, air damping can affect micromechanical devices; therefore, the energy consumed by air damping must be minimized to maximize motion of the mechanical part with a supply of limited energy.

In micromachined vibratory systems, such as gyroscopes, two damping effects can be found generally, that is, slide and squeeze film damping. Squeeze film damping is mostly due to the out-of-plane motion of the gyroscope while; on the other side, the slide film damping is due to the lateral movement of the gyroscope. The fluid flow is governed by the Navier-Stokes equation. The equations of damping, $c$, calculated by [24] from the Navier-Stokes equation are given below:

$$\begin{align*}
\frac{c}{h} &= \frac{\mu A}{h}, \\
\frac{c_{\text{combs}}}{g_c} &= \frac{2nA_{\text{combs}}\mu}{g_c + 2\lambda}.
\end{align*}$$

Equation (1) represents the damping coefficients for both fluid velocities $u$ and $v$ for no-slip boundary conditions while (2) is for the slip-boundary conditions. In (1), $n$ is the total number of combs, $A_{\text{combs}} = t \times L_c$ is overlapping area of each pair of combs, $g_c$ is the gap between the two combs, and $\lambda$ is the mean free path of the molecules of fluid.

In the proposed design, the driving motions of the two pairs of drive masses are in opposition to each other; that is, when one pair moves towards center of the gyroscope then the other pair moves away from the center and versa. Due to this drive mass movement, the overlapping area of the electrodes attached to one pair decreases while the other pair increases. This effect results in overall decrease of slide film damping [17] as compared to the prior published referred designs. Figure 8 shows the proposed gyroscope design driving masses moving configuration with thickness, $t$, and the overlap length of the combs, $L_c$. 
Figure 3: Required resonant four modes of the proposed design. (a) Driving mode, (b) X-sensing mode, (c) Z-sensing mode, and (d) Y-sensing mode.

Table 1: Electrical parameters of the proposed design.

<table>
<thead>
<tr>
<th>Types</th>
<th>Notation</th>
<th>Capacitance</th>
</tr>
</thead>
<tbody>
<tr>
<td>Driving</td>
<td>$C_{DRV}$</td>
<td>758 fF</td>
</tr>
<tr>
<td>Drive sense</td>
<td>$C_{DRS}$</td>
<td>503 fF</td>
</tr>
<tr>
<td>Coriolis sense X-gyro</td>
<td>$C_{CSX}$</td>
<td>794 fF</td>
</tr>
<tr>
<td>Coriolis sense Y-gyro</td>
<td>$C_{CSY}$</td>
<td>794 fF</td>
</tr>
<tr>
<td>Coriolis sense Z-gyro</td>
<td>$C_{CSZ}$</td>
<td>521 fF</td>
</tr>
</tbody>
</table>

4. Matlab Simulations

Simulations of the drive and sense-mode operations of the proposed design have been performed in Matlab Simulink. Due to simple implementation and zero steady state error, automatic gain control (AGC) with PI is commonly used for the self-oscillation of gyroscope [25]. A self-oscillating closed loop, utilizing PI controller, was simulated using Matlab Simulink. The electrical and mechanical parameters used during the simulation are shown in Tables 1, 2, and 3. The block diagram self-oscillating control loop is shown in Figure 9.

The closed loop transfer function of the self-oscillation loop is given by

$$H(s) = \frac{(\omega_0/2k) K_{tot} H_{cntrl}(s) V_{AC}}{S + \omega_0/2Q + (\omega_0/2k) K_{tot} H_{cntrl}(s) V_{AC}}.$$

Figure 10 shows the drive sense voltage of a single drive three axis gyroscope. The settling time was 0.7 sec at optimized values. The settling time can be further reduced by increasing the gain, which will result in high overshoot.

An open loop sense detection scheme was also simulated where the quadrature error was neglected for simplification and the individual charge amplifiers were used for the detection. Since the potential application for the proposed gyroscope is consumer electronics, angular rate of 5 dps at different amplitude was applied. As the input rate is amplitude modulated signal at the resonance frequency, a coherent demodulator was used to detect the corresponding input rate as shown in Figure 11.
Figure 4: Stress effects at the spring ends of coupling springs. (a) Design with Z-shaped spring in the coupling spring. The stress effect is reduced at the spring ends attached to the driving mass. (b) Design without the Z-shaped beam in the coupling spring. A large stress effect occurs when von Mises stress has been applied during the drive mode.

Figure 5: Design with Z-shaped beam in the coupling spring (S1). Final required mode frequency is 13515 Hz while the unwanted mode (next to the final required mode) frequency is 15587 Hz, which has a difference of 2072 Hz.

Figure 6: Design without Z-shaped beam in coupling spring (S2). Final required mode frequency is 13536 Hz while the unwanted mode (next to the final required mode) frequency is 14361 Hz, which has a difference of 825 Hz.
Figure 7: This figure shows the two designs with two mentioned coupling springs. S1 shows the design with coupling spring that contains Z-shaped beam while S2 shows the design without the Z-shaped beam in the coupling spring. The frequency difference between the required mode and the unwanted mode in case of S1 is 2072 Hz which is higher than the frequency difference of S2.

Figure 8: Driving masses motion configuration of the proposed design. When two masses move outside, then the other two masses move to the center of the device.

Figure 9: Block diagram of self-oscillating control loop.

5. Conclusion and Future Work

In this work, our focus was on the small-footprint and big-data requirement, which has been achieved by designing and simulating a single-structure triaxes gyroscope. The dimension of the device is 1428 μm × 1428 μm which is capable of measuring three mutual perpendicular axes. Due to the use of the unique coupling spring, the driving motions of the two pairs of drive masses are in opposition to each other; that is, when one pair moves towards center of the gyroscope, then the other pair moves away from the center and vice versa. Due to this drive mass movements, the overlapping area of the electrodes attached to one pair decreases while the other pair increases resulting in an overall decrease in slide film
damping. This reduction can lead to the high performance of the sensor with less requirement on vacuum level which decreases the cost of fabrication of MEMS gyroscope. The proposed design is simulated in COMSOL Multiphysics and Matlab Simulink. A Z-shaped beam has been introduced in the coupling spring for the support of the folded spring. The driving, x-sensing, z-sensing, and y-sensing are, respectively, found to be 13.30 KHz, 13.40 KHz, 13.47 KHz, and 13.51 KHz.

The device is under fabrication process. After fabrication, the testing will be performed for measuring the real quality factor, scale factor, bias stability, resolution, and bandwidth in our future study. Furthermore, instead of using individual charge amp, we are working to develop schemes for using a single charge amplifier in the sense circuit.

**Competing Interests**

The authors declare that they have no competing interests.

**Acknowledgments**

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**Table 2: Mechanical driving parameters of the proposed design.**

| Driving parameters | Frequency \((f_d)\) | Stiffness \((K_d)\) | Mass \((\text{kg})\) | Drive quality factor | Coupling spring
<table>
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<th></th>
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<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>13306 Hz</td>
<td>669 N/m</td>
<td>9.58 \times 10^{-8}</td>
<td>2500</td>
<td>Length 195 \mu m</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td></td>
<td></td>
<td>Width 4.5 \mu m</td>
</tr>
</tbody>
</table>

**Table 3: Mechanical sensing parameters of the proposed design.**

<table>
<thead>
<tr>
<th>Sensing parameters</th>
<th>Sense quality factor = 2500</th>
</tr>
</thead>
<tbody>
<tr>
<td>Frequency ((f_s))</td>
<td>Change in frequency ((f_s - f_d))</td>
</tr>
<tr>
<td>--------------------</td>
<td>-----------------------------</td>
</tr>
<tr>
<td>X-gyro</td>
<td>13407 Hz</td>
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<tr>
<td></td>
<td></td>
</tr>
<tr>
<td>Y-gyro</td>
<td>13515 Hz</td>
</tr>
<tr>
<td></td>
<td></td>
</tr>
<tr>
<td>Z-gyro</td>
<td>13515 Hz</td>
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References


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